

2815

501.39082X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

UNO, et al.

Serial No.:

09/646,671

Filed:

September 20, 2000

For:

METHOD OF FABRICATING SEMICONDUCTOR

INTEGRATED CIRCUIT DEVICE

Group:

2815

Examiner:

E. Lee

<u>AMENDMENT</u>

Commissioner or Patents P.O. Box 1450 Alexandria, VA 22313-1450 September 2, 2003

Sir:

In response to the Office Action mailed July 30, 2003, please amend the above-identified application as listed below and as set forth on the following pages:

AMENDMENTS TO THE CLAIMS

REMARKS are included following the amendments.

SEP -4 2003